



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 6, 2026	
IGI Report Number	LG805697496
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	11.44 X 8.49 X 5.77 MM

GRADING RESULTS

Carat Weight	4.88 CARATS
Color Grade	E
Clarity Grade	VS 1

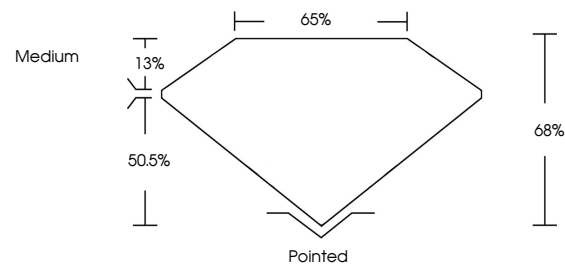
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG805697496

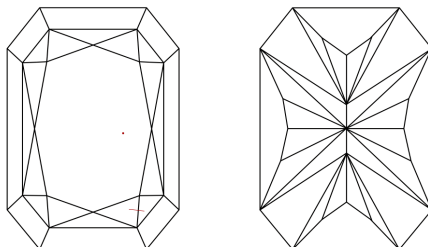
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG805697496
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

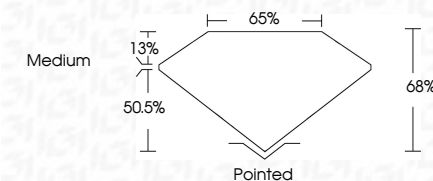
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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G Report No LG9067466	VS 1	4.88 CARATS
CUT CORNERED RECT. MODIFIED BRILLIANT	66%	
	65%	
	Medium	
Polished		
EXCELLENT		
EXCELLENT		
NONE		
NONE		
sent GARY627466		

Comments:
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created by Chemical Vapor Deposition
(CVD) growth process.